

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	Group Art Unit: 2813
Junichi SATO)	Examiner: Laura M. Schillinger
)	
Application No.: 10/828,882)	
Filed: April 21, 2004)	
)	
For: SEMICONDUCTOR THIN FILM)	
AND METHOD OF FABRICATING)	
SEMICONDUCTOR THIN FILM,)	Confirmation No.: 5622
APPARATUS FOR FABRICATING)	
SINGLE CRYSTAL SEMICONDUCTOR)	
THIN FILM, AND METHOD OF)	
FABRICATING SINGLE CRYSTAL THIN)	
FILM, SINGLE CRYSTAL THIN FILM)	
SUBSTRATE, AND SEMICONDUCTOR)	
DEVICE)	

June 29, 2007

FILED ELECTRONICALLY VIA EFS-WEB

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT ACCOMPANYING
REQUEST FOR CONTINUED EXAMINATION

Dear Sir:

Prior to further prosecution on the merits, please enter the following amendments and consider the following remarks.